

A MEMS Reconfigurable Matching Network for a Class AB Amplifier

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Abstract—This letter presents the design of a reconfigurable amplifier with an adaptive matching network implemented by shunt MEMS switches. In particular, the MEMS switches are used as capacitive stubs in double-stub matching circuit designs. The effective capacitance of the switches can be varied by switch activation which results in a change of the matching configuration. The RF response of the adaptive matching network is studied and the power performance of the amplifier is presented.

Index Terms—MEMS switch, reconfigurable amplifier.

I. INTRODUCTION

CIRCUIT reconfigurability has received tremendous attention during the past years, especially in the development of wireless communication systems. There has been considerable interest in developing adaptive components which can be electrically tuned for various applications [1], [2]. Microelectromechanical system (MEMS), on the other hand, has been demonstrated to be one of the most promising technologies in developing devices with high performance, low cost, small size and wide tunability. Particularly, it has been seen that RF MEMS switches, both capacitive and metal-to-metal contact, provide very low insertion loss, low power consumption and very high linearity in high frequency applications [3], [4]. It is believed that those MEMS devices have enormous potential in achieving circuit reconfigurability due to their superior performance and the fabrication compatibility with existing IC technology [5], [6].

In this letter, a reconfigurable amplifier is designed with a tunable input and output matching network. The matching network is tuned to provide matching at different frequencies for optimum power added efficiency (PAE) and power gain. This tunability is achieved by incorporating shunt MEMS capacitive switches into the matching network. The design issues are discussed and the circuit simulation and measurement results are presented.

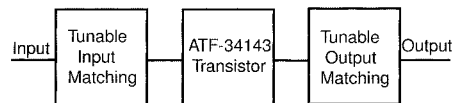


Fig. 1. Block diagram of the amplifier design.

II. RECONFIGURABLE AMPLIFIER DESIGN

A. Active Device

The transistor used in this design is Agilent ATF-34143 which is a high dynamic range, low noise PHEMT device packaged in a 4-lead SC-70(SOT-343) surface mount plastic package. The transistor has threshold voltage of -0.95 V and transconductance parameter of 0.24 A/V². Based on the device parameters and the design objective, the biased condition of the transistor is chosen to be $V_{GS} = -0.5$ V, $V_{DS} = 4$ V and $I_{DS} = 48$ mA. This corresponds to a class AB operation.

Fig. 1 shows the block diagram of the amplifier. The input matching and output matching networks provide the transistor with the optimum source and load impedances for the maximum power added efficiency and power gain. A load-pull simulation is carried out in ADS using the available device model to find out the optimum load and source impedances for the maximum power added efficiency under the particular bias condition at 8 dBm input power level. Simulation results are summarized in Table I.

B. Reconfigurable Matching Network

It is well known that a double-stub network can provide tunable matching for different impedances. Such a matching network is composed of a fixed length transmission line and two shunt stubs. The procedure of designing a double-stub matching network is described in [7]. For a given stub spacing, d , the range of G_L (the real part of the admittance) that can be matched is given by

$$0 \leq G_L \leq \frac{Y_0}{\sin^2(\beta d)}. \quad (1)$$

The two stub susceptances are determined by

$$B_1 = -B_L \pm \frac{Y_0 + \sqrt{(1+t^2)G_L Y_0 - G_L^2 t^2}}{t} \quad (2)$$

$$B_2 = \frac{\pm Y_0 \sqrt{(1+t^2)G_L Y_0 - G_L^2 t^2} + G_L Y_0}{G_L t} \quad (3)$$

Manuscript received March 7, 2003; revised July 17, 2003. This work was supported by the Multifunctional Adaptive Radio, Radar and Sensors (MARRS) MURI Project (Award Reference Number 2001-0694-02). The review of this letter was arranged by Associate Editor Dr. Rüdiger Vahldieck.

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Digital Object Identifier 10.1109/LMWC.2003.818523

TABLE I
SUMMARY OF THE OPTIMUM SOURCE AND LOAD IMPEDANCES

Frequency (GHz)	Optimum Z_{source} (ohm)	Optimum Z_{load} (ohm)
6	$8-j*23$	$31.2+j*5.5$
8	$10-j*52$	$24.2-j*0.6$

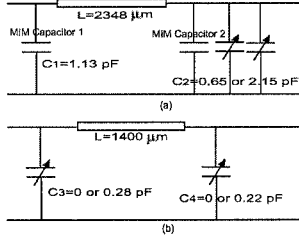


Fig. 2. Schematics of the double-stub matching network for (a) input matching and (b) output matching.

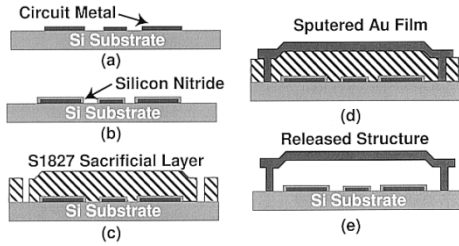


Fig. 3. Process flow for the fabrication (a) evaporation of Cr/Au and liftoff, (b) PECVD of silicon nitride deposition and RIE etching, (c) sacrificial layer deposition and patterning, (d) sputtering of Au film and patterning, and (e) device release and CO_2 critical point drying.

where B_L is the imaginary part of the load impedance, Y_0 is the character admittance and $t = \tan \beta d$. The equivalent capacitance of the two stubs can then be calculated as

$$C = \frac{B}{2\pi f}. \quad (4)$$

The input and output matching networks are designed following this procedure. Fig. 2 shows the schematics of the two double-stub tuner on a Si substrate. The stubs are implemented with both fixed value MIM capacitors and MEMS capacitive switches. As reported in [8], the implemented MEMS shunt switch behaves as a shunt capacitor between the center conductor of the CPW line and the ground. The capacitance of the switch can be varied to either C_{up} or C_{down} by activating the switch. In the input matching network [Fig. 2(a)], the second stub C_2 has capacitance of 0.65 pF (provided by MIM capacitor 2) in one configuration and 2.15 pF in the other configuration. Due to the limitation of the down capacitance that a single switch can provide, two MEMS switches are used to provide 1.5 pF when they are pulled down. In the output matching network, both stubs are implemented by one MEMS switch with down-capacitance of 0.28 pF and 0.22 pF, respectively [Fig. 2(b)]. Since the loss introduced by the MEMS switch is quite low [8], the implemented matching network has very low loss even at high frequency range.

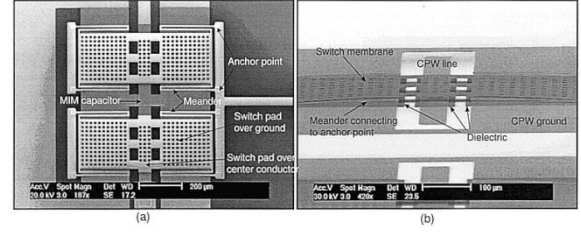


Fig. 4. (a) SEM picture of the MEMS switches at input matching network and (b) a close look of the switch.

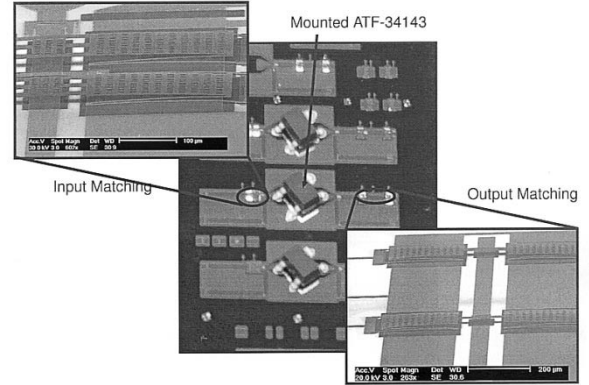


Fig. 5. Pictures of the fabricated circuits.

III. FABRICATION PROCESS

The fabrication process starts with a high resistivity Si substrate (approximately $2000 \Omega\text{-cm}$) covered with 2000 \AA SiO_2 . A lift-off process is applied to define the $40/60/40\text{-}\mu\text{m}$ finite ground coplanar waveguide (FGCPW) lines, which are made of 200 \AA of Cr and 8000 \AA of Au. 2000 \AA of silicon nitride is then deposited on the wafer with a PECVD process and a RIE process is followed to pattern the nitride layer. A sacrificial layer (S1827 photoresist by Shipley) of about $3 \mu\text{m}$ is spin coated and patterned to form the anchor points for the switch and the openings for the MIM capacitor. This is followed by a sputtering deposition of $1 \mu\text{m}$ Au film. The Au film is then patterned to form the switch membrane and the top metal layer of the MIM capacitors. The process flow is illustrated in Fig. 3 and SEM pictures of the fabricated switches are shown in Fig. 4. After the circuit is fabricated, the ATF-34 143 transistor is mounted onto the wafer using conductive epoxy adhesive. Microscope pictures of the completed circuit are shown in Fig. 5.

IV. MEASUREMENTS AND DISCUSSION

The RF performance of both input and output matching networks was measured by a 8510C Vector Network Analyzer on an Alessi Probe Station with GGP Picoprobe $150 \mu\text{m}$ pitch coplanar probes. The effects of the probes and the connecting cables were de-embedded by standard TRL calibration.

The S-parameters of the matching network are shown in Fig. 6. Fig. 6(a) and (b) shows the response of the input matching network at two design configurations. At the 6 GHz configuration, both switches are pulled down. While at the 8 GHz configuration, both switches are up. Fig. 6(c) and (d)

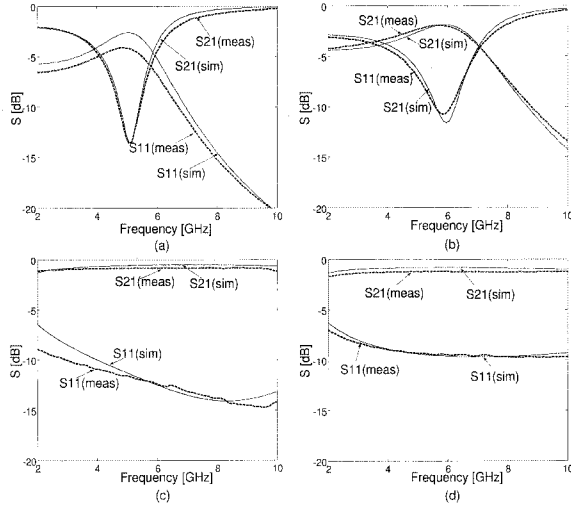


Fig. 6. Measured and simulated response of (a) the input matching network at 6 GHz configuration, (b) the input matching network at 8 GHz configuration, (c) the output matching network at 6 GHz configuration, and (d) the output matching network at 8 GHz configuration.

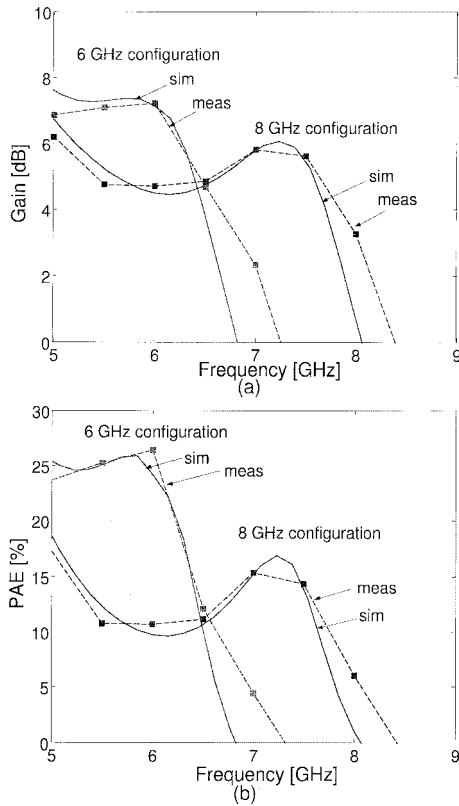


Fig. 7. The measured and simulated power performance of the reconfigurable amplifier (a) power gain and (b) PAE.

show the S-parameters of the output matching network. In the 6 GHz design configuration, the first switch (C_3) is up and the second switch (C_4) is down (see Fig. 2). While at the 8 GHz configuration, C_3 is down and C_4 is up. Both measured and simulated S-parameters are shown in this figure.

TABLE II
SUMMARY OF THE POWER PERFORMANCE OF THE AMPLIFIER

	Configuration 1	Configuration 2
MAG (dB)	8.7	6.7
Measured Gain(dB)	7.2	6.1
Simulated PAE (%)	24.2	16.9
Measured PAE(%)	26.4	16.7

The power gain and PAE of the amplifier were measured by connecting the input port to a HP 83624A Synthesized Sweeper and the output port to a HP 8564E Spectrum Analyzer. To calibrate the test setup, the circuit was replaced with a through line and the loss of the connecting cables and probes were measured. At the bias condition described in Section II and $P_{in} = 8$ dBm, I_{DS} , V_{DS} , and P_{out} of the amplifier were recorded at the two matching configurations. The power gain and PAE are calculated as

$$\text{Gain} = \frac{P_{out}}{P_{in}}, \quad \text{PAE} = \frac{P_{out} - P_{in}}{V_{DS}I_{DS}}. \quad (5)$$

The results are shown in Fig. 7. Simulation results are also given in the figure. The PAE and gain are improved at high frequency when the matching network is switched from configuration 1 (6 GHz design) to configuration 2 (8 GHz design). Table II summarizes the Maximum Available Gain (MAG), simulated PAE, the measured gain and PAE at two peak frequencies.

V. CONCLUSION

We have demonstrated a reconfigurable amplifier design with maximum PAE and power gain at 6 GHz and 8 GHz. The adaptive matching networks are implemented with MEMS capacitive switches to provide matching conditions for both input and output at different frequencies. The RF responses of the matching networks at two design configurations are measured as well as the power performance of the amplifier. This technique can be applied to other circuit designs where reconfigurability of the circuit is required.

REFERENCES

- [1] G. Ferri, "Low-voltage low-power adaptive biased high-efficiency integrated amplifiers," in *Proc. IEEE 8th Int. Conf. Electronics, Circuits and Systems*, vol. 3, 2001, pp. 1529–1532.
- [2] K. Nishikawa and T. Tokumistu, "An MMIC low-distortion variable-gain amplifier using active feedback," *IEEE Trans. Microwave Theory Tech.*, vol. 43, pp. 2812–2816, Dec. 1995.
- [3] G. M. Rebeiz and J. B. Muldavin, "RF MEMS switches and switch circuits," *IEEE Microw. Mag.*, pp. 59–71, Dec. 2001.
- [4] D. Peroulis, K. Sarabandi, and L. P. B. Katehi, "Low contact resistance series MEMS switches," in *IEEE MTT-S Int. Microwave Symp. Dig.*, vol. 1, June 2002, pp. 223–226.
- [5] E. R. Brown, "RF-MEMS switches for reconfigurable integrated circuits," *IEEE Trans. Microwave Theory Tech.*, vol. 46, no. 11, pp. 1868–1880, Nov. 1998.
- [6] K. L. Lange, J. Papapolymerou, C. L. Goldsmith, A. Malczewski, and J. Kleber, "A reconfigurable double-stub tuner using MEMS device," in *IEEE MTT-S Int. Microwave Symp. Dig.*, vol. 1, 2001, pp. 337–340.
- [7] D. M. Pozar, *Microwave Engineering*. New York: Wiley, 1998.
- [8] D. Peroulis, S. Pacheco, K. Sarabandi, and L. P. B. Katehi, "Tunable lumped components with applications to reconfigurable MEMS filters," in *IEEE MTT-S Int. Microwave Symp. Dig.*, vol. 1, June 2001, pp. 341–344.